

<b>Notice of References Cited</b>	Application/Control No. 10/581,884		Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Vu Nguyen		Art Unit 1796	Page 1 of 1

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*	B	US-2005/0265950 A1	12-2005	Chrisstoffels et al.	424/070.17
*	C	US-7,015,294 B2	03-2006	Dausch et al.	526/319
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#### NON-PATENT DOCUMENTS

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